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** CONTINUING DATA *****

This application is a CIP of 10/404,693 03/31/2003

YES

** FOREIGN APPLICATIONS *****

NONE

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 7	TOTAL CLAIMS 37	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature Initials				

ADDRESS

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TITLE

Method of porogen removal from porous low-k films using UV radiation